

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masahiko Ando, et al.

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed: July 11, 2001

Examiner: Not Yet Assigned

For: THIN FILM TRANSISTOR, LIQUID
CRYSTAL DISPLAY AND
MANUFACTURING METHOD
THEREOF

PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

Preliminary to examination, please amend the above-referenced application as follows:

IN THE SPECIFICATION:

Page 8, rewrite the paragraph beginning on line 1 as follows:

Figs. 1(a) through 1(e) illustrate a thin film transistor and the manufacturing process thereof according to a first embodiment;

Page 8, rewrite the paragraph beginning on line 6 as follows:

Figs. 3(a) through 3(e) illustrate a thin film transistor and the manufacturing process thereof according to a second embodiment;

Page 8, rewrite the paragraphs beginning on lines 10 and 12 as follows:

Figs. 5(a) through 5(f) illustrate a thin film transistor and the manufacturing process thereof according to a third embodiment; and

Figs. 6(a) through 6(d) illustrate a conventional channel etched type thin film transistor and the manufacturing steps thereof.

REMARKS

The application has been editorially revised. Favorable action on the application is solicited.

Dated: July 11, 2001

Respectfully submitted,

By 

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